



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re Application of: Nathan R. Brown

Serial No.: 10/715,264

Filed: November 17, 2003

For: METHODS FOR DETERMINING AMOUNTS AND LOCATIONS OF DIFFERENTIAL PRESSURE TO BE APPLIED TO SEMICONDUCTOR SUBSTRATES DURING POLISHING OF SEMICONDUCTOR DEVICE STRUCTURES CARRIED THEREBY AND FOR SUBSEQUENTLY POLISHING SIMILAR SEMICONDUCTOR DEVICE STRUCTURES

Confirmation No.: 5086

Examiner: S. Macarthur

Group Art Unit: 1763

Attorney Docket No.: 2269-4375.3US
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**AMENDMENT ACCOMPANYING
REQUEST FOR CONTINUED EXAMINATION (RCE)**

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner:

This Amendment accompanies a Request for Continued Examination (RCE) in the above-referenced application, which is being submitted with a petition for a one month time extension and the appropriate fee within four months of the October 6, 2006, mailing date of a final Office Action.

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A listing of claims, in which revisions to the claims are presented, begins on page 3 of this paper; and

Remark start at page 7 of this paper.